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INF	INFORMATION DISCLOSURE			Application Number	10/722,700	
STATEMENT BY APPLICANT				Filing Date	November 25, 2003	
				First Named Inventor	Loucas Tsakalakos et al.	
(Use as many sheets as necessary)			cessary)	Art Unit	1754	
				Examiner Name	Rebecca M. Stadler	
Sheet	1	of	2	Attorney Docket Number	139081-1/SWA (GERD:0662)	

			U.S.	PATENT DO	CUMENTS	
Examiner Initials*	Cite No. <sup>1</sup>	ľ	Pocument Number per-Kind Code <sup>2 (If known)</sup>	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
ven	A1	US-	2003205966	11/06/2003	Chen Lai-Cheng et al.	
"   '	A2	US-	2003087511	05/08/2003	Hidaka Kishio et al.	
	A3	US-	2003030356	02/13/2003	Fran Yui-Shin et al.	
	A4	US-	5,314,569	05/24/1994	Pribat et al.	
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	A18	US-				
	A19	US-		1		

Examiner Initials*	Cite	Foreign Patent Document	Publication	Name of Patentee or	Pages, Columns, Lines,		
	No.1	Country Code <sup>3-</sup> Number <sup>4-</sup> Kind Code <sup>5(if known)</sup>	Date MM-DD-YYYY	Applicant of Cited Document	Mhan Dalaman Danasan	T*-	
	B1-	WO03048040	06/12/2003	Theles			
	B2	WO03025966	03/27/2003	Thales			
	В3	WO03018466	03/06/2003	SI Diamond Tech		1	
	B4						
	B5						
	B6						

Examiner Signature Date Considered 4/30/2007

\*EXAMINER initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. 'Applicant's unique citation designation number (optional). 'See Kinds Codes of USPTO Patent Documents at <a href="https://www.uspto.gov">www.uspto.gov</a> or MPEP 901.04. 'Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). 'For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. 'Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. 'Applicant is to place a check mark here if English language Translation is attached. This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissionier for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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Sheet	1	of	2	Attorney Docket Number	139081-1/SWA (GERD:0662)	

		NON PATENT LITERATURE DOCUMENTS				
Examiner Initials Cite No. 1						
		TSAKALAKOS, LOUCAS ET AL.: "Mo2C Nanowires and Ribbons on Si Via Two-Step Vapor Phase Growth," Proceedings of the 3rd ASME Integrated Nanosystems Conference-Design, Synthesis, and Applications; 2004, pages 129-130.				
ı	C2	SHAJAHAN MD. ET AL.: "Effect of Chemical Vapor Deposition Energy Sources on the Structure of SiC Prepared by Carbon Nanotubes-Confined Reaction," Journal of Vacuum Science & Technology B: Microelectronics Processing and Phenomena, American Vacuum Society, New York, NY, US, vol. 21, no. 3, May 2003, pages 1149-1156.	(4.) Op =: (1) Is (1) inh()			
	C3	ING-CHI LEU ET AL.: "Nucleation Behavior of Silicon Carbide Whiskers Grown by Chemical Vapor Deposition," Journal of Crystal Growth Elsevier Netherlands, vol. 236, no. 1-3, 1 March 2002, pages 171-175.				
·	C4	FUKUNAGA, AKIHIKO ET AL.: "Synthesis, Structure, and Superconducting Properties of NbC Nanorods and Nanoparticles," Materials Transactions, JIM, Feb. 1999 Japan Inst. of Metals, Sendai, Japan, vol. 40, no. 2, February 1999, pages 118-122.				
	C5	LIEBER, CHARLES M. ET AL.: "Growth and Structure of Carbide Nanorods," Materials Research Society Symposium Proceedings; Covalent Ceramics III – Science and Technology of Non-Oxides; Materials Research Society, Pittsburgh, PA, USA, vol. 410, 27 November 1995, pages 103-111.				
V	C6	KATO ET AL.: "Formation of Micro SiC Tubes by the Carburization of Si Whiskers," Journal of the American Ceramic Society USA, vol. 63, no. 3-4, March 1980, page 236.	ا سرعه			
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